

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 294550US41PCT		SERIAL NO. 10/588,703	
LIST OF REFERENCES CITED BY APPLICANT				APPLICANT Jean DIJON, et al.		GROUP <u>1248</u>	
				FILING DATE August 8, 2006			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AG						
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	AI						
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	AF						
	AM						
	AN						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES NO		
	AC						
	AF						
	AQ						
	AR						
	AS						
	AT						
	AU						
	AV						
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)							
/M.L.P./	AW	Office Action issued May 10, 2011, in Japan Patent Application No. 2006-551895, filed April 28, 2011, (with English-language Translation) only translations supplied-no original JPO document found					
/M.L.P./	AX	C M. Cotell, et al., "Microstructural Development of Thin Films Grown by Pulsed Laser Deposition." <i>Materials Science and Engineering B32</i> (1995) 221-230 (no month)					
/M.L.P./	AY	Masako Yudasaka et al., "Specific Conditions for Ni Catalyzed Carbon Nanotube Growth by Chemical Vapor Deposition," <i>Appl Phys Lett</i> 67 (17) October 23, 1995					
	AZ						<input type="checkbox"/> Additional References sheet(s) attached
Examiner <u>Marianne Padgett</u>					Date Considered <u>11/10/2011</u>		
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 809; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

previously cited in an 11/7/06 IDS &
previously considered (10/14/09)